

April 27, 2024

Description

Measurements

Carat Weight

Color Grade

Clarity Grade

Cut Grade

Polish

Symmetry

Fluorescence

Inscription(s)

Type IIa

GRADING RESULTS

IGI Report Number

Shape and Cutting Style

ADDITIONAL GRADING INFORMATION

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth

process and may include post-growth treatment.

GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

55% Medium To 16% Slightly Thick (Faceted) 42.5% Pointed

PROPORTIONS

LG632429342

DIAMOND ROUND BRILLIANT

2.08 CARATS

Е

VS 1

IDEAL

EXCELLENT

EXCELLENT

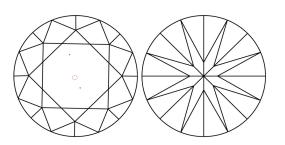
1/51 LG632429342

NONE

LABORATORY GROWN

8.16 - 8.21 X 5.07 MM

CLARITY CHARACTERISTICS



LABORATORY GROWN DIAMOND REPORT

LG632429342 Report verification at igi.org

34.8°

40.6°

61.9%

KEY TO SYMBOLS

Red symbols indicate internal characteristics. Green symbols indicate external characteristics. LABORATORY GROWN DIAMOND REPORT

GRADING SCALES

CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	l ¹⁻³
Internally	Very Very	Very	Slightly	Included
Flawless	Slightly Included	Slightly Included	Included	

COLOR

D E F G H I J Faint Very Light Ligh	D	Е	F	G	Н	Т	J	Faint	Very Light	Light
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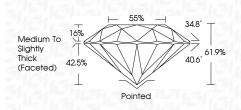


Sample Image Used

LABORATORY GROWN DIAMOND REPORT

April 27, 2024

IGI Report Number	LG632429342				
Description	LABORATORY GROWN DIAMOND				
Shape and Cutting Style	ROUND BRILLIANT				
Measurements	8.16 - 8.21 X 5.07 MM				
GRADING RESULTS					
Carat Weight	2.08 CARATS				
Color Grade	IC I STATE I CE				
Clarity Grade	V\$ 1				
Cut Grade	IDEAL				



ADDITIONAL GRADING INFORMATION

Type IIa

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	(G) LG632429342
Comments: This Laboratory created by Chemical Vapo	or Deposition (CVD) growth



	197										
	187	IDEAL	61.9%	55%	Medium To Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	AGN LG632429342	bry Grown Diamond was Chemical Vapor Deposition th process and may include
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